

APPLICATION DATA SHEET

Electronic Version 0.0.11

Stylesheet Version: 1.0

Publication Filing Type: new-utility

Application Type: utility

Title of Invention: METHOD FOR DEPOSITING THIN FILM USING PLASMA CHEMICAL VAPOR DEPOSITION

Attorney Docket Number: 9458-US-PA

Customer Number Attorney: 31561



Customer Number Correspondence Address: 31561



INVENTOR(s):

Primary Citizenship: TAIWAN

Given Name: Frank

Family Name: Lin

Residence City: Hsinchu

Residence Country: TW

Address: No.99-5, Shan-Chu Hu, Hsiu-Hu Tsun, Hsiunglin
Hsinchu , 307 TW